

10/05/01
jc961 U.S. PTO

01-08-01

Atty. Docket No. AMAT/5538/CMP/CMP/RKK

A
JC961 U.S. PTO
01/05/01

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Box Patent Application

Assistant Commissioner of Patents and Trademarks
Washington, D.C. 20231

Re: Inventor(s): LIZHONG SUN, STAN D. TSAI, SHIJIAN LI and FENG LIU
Title: TANTALUM REMOVAL DURING CHEMICAL MECHANICAL POLISHING

Transmitted herewith is the patent application identified above, including:

- Specification, claims and abstract, totaling 27 pages.
- Drawings totaling 3 pages, X Formal Informal.
- Executed Declaration and Power of Attorney.
- Information Disclosure Statement w/ Form 1449 and References.
- Assignment of the invention to **Applied Materials, Inc.**

Assignment Recordation Cover Sheet

FEE CALCULATION					
Fee Items	Claims Filed	Included With Basic Fee	Extra Claims	Fee Rate	Total
Total Claims	67	-20=	47	x \$18.00	\$846.00
Independent Claims	4	-3=	1	x \$80.00	\$ 80.00
Basic Filing Fee				\$710.00	\$710.00
TOTAL FEES					\$1636.00

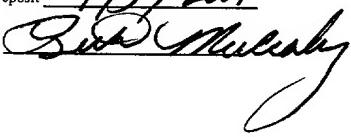
- The Commissioner is hereby authorized to charge \$1636.00 to Deposit Account No. 50-1074/5538/RWM.
- The Commissioner is hereby authorized to charge any additional fees which may be required, or credit any overpayment to Deposit Account No. 50-1074/5538/RWM. A duplicate copy of this transmittal is enclosed.
- Please address all future correspondence to:

PATENT COUNSEL
APPLIED MATERIALS, INC.
Legal Affairs Department
P.O.BOX 450A
Santa Clara, CA. 95052

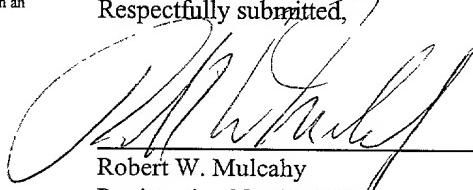
I hereby certify that this correspondence is being deposited with the United States Postal Service as express mail in an envelope addressed to Commissioner of Patents and Trademarks, Washington, D.C. 20231

Express Mail Receipt No EL684621816US

Date of Deposit 1/5/2001

Signature 

Respectfully submitted,


Robert W. Mulcahy
Registration No. 25,436
(713) 623-4844